



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 3, 2026	
IGI Report Number	LG805642147
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	6.64 X 4.89 X 3.44 MM

GRADING RESULTS

Carat Weight	1.08 CARAT
Color Grade	E
Clarity Grade	VS 2

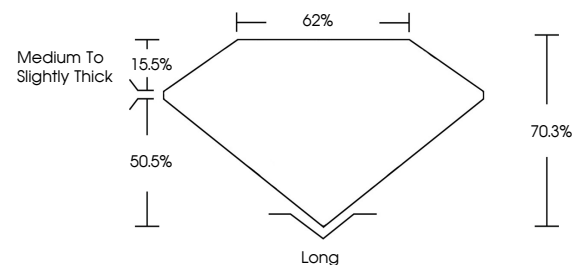
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG805642147

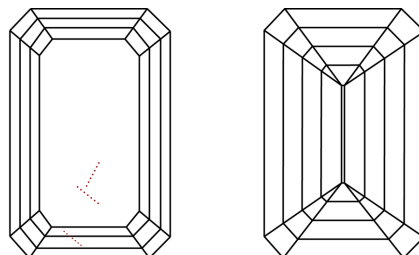
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG805642147
Report verification at igi.org

PROPORTIONS

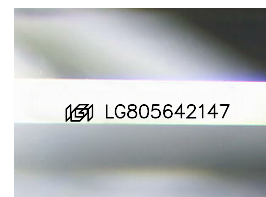


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

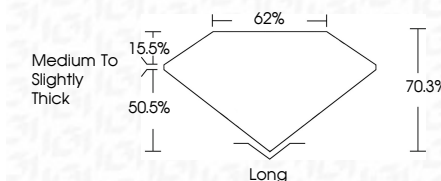
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www.igi.org

June 3, 2026
GI Report No LG805642147

GI Report No. LG905642.147	1.08 CARAT
HERAUD CUT	E
6.64 X 4.89 X 3.44 MM	VS 2
	70.3%
	62%
	Medium To Slightly Thick
	Long
	EXCELLENT
	EXCELLENT
	NONE
	Very Clean to Very

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.